



Docket No. 740756-2205

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Ritsuko KAWASAKI et al.

Application No. 09/651,889

Filed: August 30, 2000

For: SEMICONDUCTOR DEVICE,
MANUFACTURING METHOD
THEREOF AND ELECTRONIC
DEVICE

)
) Confirmation No. 2171
) Group Art Unit: 2814
) Examiner: Dana Farahani
)
)
) May 12, 2004
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CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

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Signature: Deborah Movahhedi
Name: Deborah Movahhedi

REQUEST FOR RECONSIDERATION

Mail Stop **AFTER FINAL**
Commissioner for Patents
P.O. Box 1450
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Dear Sir:

In response to the Examiner's Office Action dated January 12, 2004, please consider the following amendments and remarks in connection with the above-identified application.